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Sheet	1			of	2	

	Complete if Known	1
Application Number	10/072,656	
Filing Date	February 7, 2002	
First Named Inventor	Eric Prophet	
Group Art Unit	2811	
Examiner Name	Not Yet Assigned	
Attorney Docket Number	269/132	

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	0	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevar
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Signature Zoke Considered 8/20/03	Examiner Signature	Loke	Date Considered	8/20/03	
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